

Configuration **G7E** Check Sheet

1	Check Data		Inspector		
2	End User				
3	Machine model	1505 G7E	Serial Number		
4	Electric source	NEMA BOXFor (CVCF/UPS) / NEMA Switch(none/1/2)			
5	Chamber Type	Maker	ASAHI	Production date	1989.09
		S/N	50319	Model	S75
6	Chamber Size	Body(1500mm)		Chamber EPROM Ver	
7	Set Temperature	Chamber :	23.0℃	LLTC:	
				IATC:	
8	Computer Type	NEST3			
9	MCSV Ver.				
10	ROM Version	Reticle Loader		Reticle Stage	
		Operation panel		Lens Controller	
		Wafer Stage		Wafer Loader	
				Wafer Sensor	
11	HP LASER	5517A/ 5517B / 5517C / 5517D			
12	LAMP Power	1kW/ 1.5kW / 1.75kW / 2kW	LSA LASER	5mW / 10mW / 無	
13	Reticle Microscope	Fixed / Variable / setting size (15 mm)			
14	Wafer Codition	Sapphire/ Silicon / Other() / Wafer Size (3")			
15	Wafer Stage	Ball screw/ Lead screw	Chuck Type	Ring/ Pin	
16	OF Detection Type	Nikon Original Type /Omron type/ Keyence type / 8inch Notch type			
17	Wafer Loader Type	TYPE1/ TYPE2 / TYPE3	Wafer Type	Flat/ Notch	
18	Wafer Carrier Table	Left / Right / Extra	In-line	no/ yes (right / left)	
19	Reticle Size	5inch/ 6inch	FIA/LIA	no/ yes,no/ yes	
20	Reticle Library Type	Nikon/ Canon	Slot	Main: (13)Slot / Ext. LIB : () Slot	
21	PPD/PD	PPD (no/yes) PD(no/yes)			
22	Rack Type	Nomal(Right / Left) / Special			
23	SHRINC Type	None/ 1 / 2 / 3	Illumination Setting	-	
24	NOTE	Missing Part :LSA Laser 1ea , Lamp Power Supply 1ea			